

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re DIVISIONAL application of)
Ritsuko KAWASAKI et al.)
Based on Serial No. 09/640,077) Group Art Unit: 2813
Filed: August 17, 2000) Examiner: L. Schillinger
For: SEMICONDUCTOR DEVICE AND)
METHOD OF FABRICATING THE SAME)

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith a Form PTO-1449 listing references known to Applicant and requests that these references be made of record in the above identified application. Copies of the references listed are submitted herewith in accordance with 37 C.F.R. 1.98(a).

U.S. Patents 5,643,826; 5,923,962; 6,285,042 and 6,335,541 correspond to Japanese Patent Laid Open No. 07-130652.

The references listed on the attached Form PTO-1449 were cited in parent application Serial No. 09/640,077 and copies of the references can be found in that application.

Respectfully submitted,



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Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Complete if Known			
				Application Number		Based on 09/640,077	
				Filing Date		August 17, 2000	
				First Named Inventor		Ritsuko KAWASAKI, et al.	
				Group Art Unit		2813	
				Examiner Name		Laura Schillinger	
Sheet	1	of	2	Attorney Docket Number		0756-7181	

U.S. PATENT DOCUMENTS						
Examiner Initials ¹	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
		5,923,962		Ohtani et al.	07/13/99	
		5,643,826		Ohtani et al.	07/01/97	

FOREIGN PATENT DOCUMENTS							
Examiner Initials ¹	Cite No. ¹	Foreign Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Office ³	Number ⁴ (if known)				
		JP	07-130652		05/19/95		Abst.

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS			
Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		K. Shimizu et al., "High-Mobility Poly-Si Thin-Film Transistors Fabricated by a Novel Excimer Laser Crystallization Method," IEEE Transactions on Electron Devices, Vol. 40, No. 1, pp. 112-117, 1993.	
		Ishihara et al., "Location-Controlled Adjacent Grains Following Excimer-Laser Melting of Si Thin-Films," 1998, pp. 153-156, AM-LCD.	
		Specifications and Drawings for Application Serial No. 09/696,165, "Semiconductor Device and Method of Manufacturing the Same," Filed on 10/26/00, pp. 1-63, 33 pages of drawings, Inventors: Ritsuko KAWASAKI, et al.	
		Specifications and Drawings for Application Serial No. 09/598,827, "Method of Fabricating a Semiconductor Device," Filed on 06/21/00, pp. 1-64, 25 pages of drawings, Inventor: Kenji KASAHARA.	
		Specifications and Drawings for Application Serial No. 09/732,724, "Semiconductor Device and A Method of Manufacturing the Same," Filed on 12/11/00, pp. 1-50, 26 pages of drawings, Inventors: Ritsuko KAWASAKI et al.	
		Ishihara et al., "Location Control of Large Grain Following Excimer-Laser Melting of Si Thin-Films," March 1998, pp. 1071-1075, Japanese Journal of Applied Physics, Vol. 37, Pt. 1, No. 3B.	

Examiner Signature	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

¹ Unique citation designation number. ² Applicant is to place a check mark here if English language Translation is attached.

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		Number	Kind Code ² (if known)			
		5,893,730		Yamazaki et al.	04/13/99	
		6,078,070		Robinson	06/20/00	
		6,107,107		Bruce et al.	08/22/00	
		6,245,602		Ho et al.	06/12/01	
		5,811,322		Robinson	09/22/98	
		5,841,197		Adamic Jr.	11/24/98	
		6,346,438		Yagishita et al.	02/12/02	
		6,285,042		Ohtani et al.	09/04/01	
		6,335,451		Ohtani et al.	01/01/02	
		6,492,659		Yamazaki et al.	12/10/02	

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		Office ³	Number ⁴ Kind Code ⁵ (if known)			
		JP	2001-203360		07/27/01	Full

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²

Examiner Signature	Date Considered
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